

Electronic Information Disclosure Statement

PROCESS FOR A MONOLITHICALLY- INTEGRATED MICROMACHINED SENSOR AND CIRCUIT

JC930 U.S. PRO
10/065448



10/16/02

Application:

Confirmation:

Applicant(s): Abhijeet Chavan

Docket Number: DP-307129

Group Art Unit:

Examiner:

search string: (5059543 or 5689087 or 5982014).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
<i>M</i>	P01	5059543	1991-10-22		Wise, et al	437	3
<i>M</i>	P02	5689087	1997-11-18		Jack	136	213
<i>M</i>	P03	5982014	1999-11-09		Paige	257	467

Signature

Examiner Name	Date
	